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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Isamu Kobori et al. Art Unit : 2811
Serial No. : 10/623,581 Examiner : Unknown
Filed : July 22, 2003
Title : METHOD OF MANUFACTURING A SEMICONDUCTOR METHOD OF
MANUFACTURING A THIN-FILM TRANSISTOR AND THIN-FILM
TRANSISTOR

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

REQUEST FOR CORRECTED OFFICIAL FILING RECEIPT

Please correct the Filing Receipt for the above-referenced application to include the correct number of drawings. The correct number of sheets of drawings is six (6).

Please supply a corrected Filing Receipt to the undersigned with respect to this application. A copy of the original Filing Receipt showing the desired changes in red ink is attached for your convenience.

No fee is believed to be due. If, however, there are any charges or credits, please apply them to Deposit Account No. 06-1050.

Respectfully submitted,

Date: 5/17/04



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10/623,581	07/22/2003	2811	1014	07977-024003	6 X	30	4

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CONFIRMATION NO. 6534

FILING RECEIPT



OC000000012477624

Date Mailed: 04/29/2004

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Applicant(s)

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Assignment For Published Patent Application

Semiconductor Energy Laboratory Co., Ltd.;
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Domestic Priority data as claimed by applicant

This application is a DIV of 09/016,999 02/02/1998 PAT 6,596,572
 which is a DIV of 08/623,506 03/28/1996 PAT 5,767,529

Foreign Applications

JAPAN 7-96266 03/28/1995

If Required, Foreign Filing License Granted: 04/28/2004

Projected Publication Date: 08/05/2004

Non-Publication Request: No

Early Publication Request: No

Title

Method of manufacturing a semiconductor method of manufacturing a thin-film transistor and thin-film transistor

Preliminary Class

257

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